

SHEET 1 OF 1

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Substitute for form 1449/PTO)				ATTY. DOCKET NO. 060188-0707		SERIAL NO. 10/715,433	
				APPLICANT Masayuki ENDO, et al.			
				FILING DATE November 19, 2003		GROUP 2813	
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
		US 5,880,169	03-09-1999	OSAWA et al.	Corresponds to JP 09-323970		
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EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Code ¹ -Number & Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation Yes No	
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.					
		Japanese Office Action, with English Translation, issued in Corresponding Japanese Patent Application No. 2003-177884, dated on October 30, 2007					
		SWITKES et al. "Resolution Enhancement of 157 nm Lithography by Liquid Immersion", OPTICAL MICROLITHOGRAPHY XV, Proceedings of SPIE Vol. 4691, pages 459-465 March 5-8, 2002					
EXAMINER /James Mitchell/				03/01/2008 DATE CONSIDERED			

*EXAMINER: (initial) If reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /J.m.m